

BEST AVAILABLE COPY

08-02-'05 10:36 FROM-TUNG & ASSOCIATES

12485404035

T-413 P01/14 U-662

U.S.S.N. 10/050,322

RECEIVED
CENTRAL FAX CENTER

AUG 02 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Tsai et al.

Group Art Unit: 1756

Serial No.: 10/050,322

Examiner: N. M. Barreca

Filed: 01/15/2002

In Response to Office Action
Dated: 07/07/2005


For: A BI-LAYER PHOTORESIST DRY DEVELOPMENT AND REACTIVE ION
ETCH METHOD

Attorney Docket No.: 67,200-613

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

I hereby certified that this correspondence is (1) ☐ being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P O Box 1450, Alexandria, VA 22313-1450 on August 2, 2005; or (2) ☒ being facsimile transmitted to the United States Patent and Trademark Office at facsimile number (571)-273-8300 on August 2, 2005.

Randy W. Tung
Printed Name


Signature

8/2/05
Date

Please forward all correspondence to
TUNG & ASSOCIATES
838 W. Long Lake Road, Suite 120
Bloomfield Hills, MI 48302

U.S.S.N. 10/050,322

Second SUPPLEMENTAL AMENDMENT

Assistant Commissioner
for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 07/07/2005 please
allow entry of the following amendments to place the Application
in better form for Appeal.